APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2641

Publication Filing Type:

new-utility

Application Type:

utility

Title of Invention:

PROCESS FOR PRODUCTION OF SOI SUBSTRATE AND PROCESS FOR

PRODUCTION OF SEMICONDUCTOR DEVICE

Suggested Representative Figure:

Figs. 1A

Legal Representative:

Attorney or Agent:

Jeffrey L. Costellia

Registration Number:

35483

Attorney or Agent:

Donald R. Studebaker

Registration Number:

32815

Customer Number Correspondence Address:

22204

22204

Continuity Data:

This application is a division of $09/907,911\ 2001-07-19$ Pending

which is a division of 09/356,704 1999-07-20 Issued

Foreign Priority:

10-214125

JP 1998-07-29

Priority Claimed

Assignee (Publish): SEMICONDUCTOR ENERGY LABORATORY CO., LTD.

398, Hase,

Atsugi-shi 243-0036 Kanagawa-ken JP

INVENTOR(s):

Primary Citizenship:

Japanese

Given Name:

Takeshi

Family Name:

FUKUNAGA

Residence City:

Kanagawa

Residence Country:

JP

Address

c/o Semiconductor Energy Laboratory Co., Ltd., 398, HAse

Atsugi-shi Kanagawa-ken, 243-0036 JP